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MAR 03 2004

Serial No. 09/825,973

OKI.227

Amendment dated February 25, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Norio Hirashita et al.

Group Art Unit: 2823

Serial No.: 09/825,973

Examiner: J. Maldonado

Filed: April 5, 2001

Confirm. No.: 3710

For: A STRUCTURE OF A FIELD EFFECT TRANSISTOR HAVING METALLIC
SILICIDE AND MANUFACTURING METHOD THEREOF

AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Date: February 25, 2004

Sir:

In response to the Office Action dated September 25, 2003, the period for response having been extended two (2) months to February 25, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.